



**ELECTRONIC COPY**

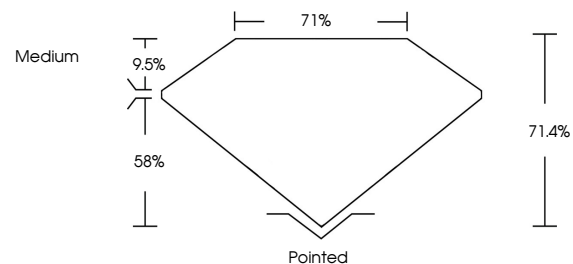
**LABORATORY GROWN DIAMOND REPORT**

June 5, 2026  
IGI Report Number **LG807648341**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **PRINCESS CUT**  
Measurements **5.54 X 5.52 X 3.94 MM**  
**GRADING RESULTS**  
Carat Weight **1.04 CARAT**  
Color Grade **E**  
Clarity Grade **VS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG807648341**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

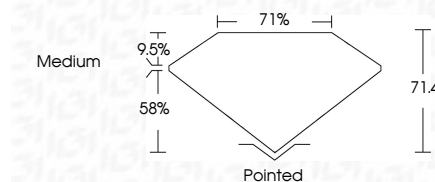
| FL       | IF                  | VS <sup>1-2</sup>           | VS <sup>1-2</sup>      | SI <sup>1-2</sup> | I <sup>1-3</sup> |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included         |



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**IGI**



June 5, 2026  
IGI Report No **LG807648341**  
**PRINCESS CUT**  
**1.04 CARAT**  
Color Grade **E**  
Clarity Grade **VS 2**  
Table **9.5%**  
Depth **58%**  
Width **71%**  
Height **71.4%**  
Girdle **Medium**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
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